

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

WANG

Serial No.: 10/052,475

Filed: January 17, 2002

Title: ADVANCED CHEMICAL
MECHANICAL POLISHING SYSTEM WITH
SMART ENDPOINT DETECTION

Group Art Unit: 3723
Examiner: D. Thomas
Docket: NT-238-US

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the US Postal Service as First Class Mail in
a postage-paid envelope addressed to the Commissioner
for Patents, P.O. Box 1450, Alexandria, VA 22313 on
December 3, 2003.

Signed:

Amy A. Wine

AMENDMENT B

Commissioner for Trademarks
P.O. Box 1450
Alexandria, VA 22313

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DEC 10 2003

TECHNOLOGY CENTER R3700

Dear Sir:

In response to the Office Action mailed September 8, 2003, Applicant petitions for entry and consideration of the following Remarks and Amendment. Please amend the above-identified application as follows:

The Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.